Docket: 0756-7181

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	DIVISIONAL application of)	
Ritsu	uko KAWASAKI et al.)	
Base	ed on Serial No. 09/640,077)	Group Art Unit: 2813
Filed	f: August 17, 2000)	Examiner: L. Schillinger
For:	SEMICONDUCTOR DEVICE AND)	
	METHOD OF FABRICATING THE SAME)	

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

U.S. Patents 5,643,826; 5,923,962; 6,285,042 and 6,335,541 correspond to Japanese Patent Laid Open No. 07-130652.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/640,077 and copies of the references can be found in that application.

Respectfully submitted,

Eric J. Robinson

Reg. No. 38,285

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Substitute	for form 1449A/PTO			C	omplete if Known
INFO	DMATION I	nisci	OSHIDE	Application Number	Based on 09/640,077
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Fiting Date	August 17, 2000		
SIA				First Named Inventor	Ritsuko KAWASAKI, et al.
1	(use as many sheets of	as necesso	ary)	Group Art Unit	2813
				Examiner Name	Laura Schillinger
Sheet	1	of	2	Attorney Docket Number	0756-7181

				U.S. PATENT DOCUMEN	rs		
Examiner Initials	Cite No ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number	Kind Code ² (if known)	Document	MM-DD-YYYY	,	
	1	5,923,962		Ohtani et al.	07/13/99		
	1	5,643,826		Ohtani et al.	07/01/97		

		FO	REIGN PATENT DOC	JMENTS		, , , , , , , , , , , , , , , , , , ,				
Examiner Initials*	Cite No.1	Foreign Patent Document Kind Code ¹ Office ¹ Number ⁴ (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T _€				
		JP 07-130652		05/19/95		Abst.				
		OTHER PRIOR A	ART – NON PATENT LITE	RATURE DOCUMENTS						
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc)., date, page(s), volume-issue number(s), publisher, city and/or country where published.								
		K. Shimizu et al., "High-Mobility Poly-Si Thin-Film Transistors Fabricated by a Novel Excimer Laser Crystallization Method," IEEE Transactions on Electron Devices, Vol. 40, No. 1, pp. 112-117, 1993.								
8		Ishihara et al., "Location-Controlled Adjacent Grains Following Excimer-Laser Melting of Si Thin-Films," 1998, pp. 153-156, AM-LCD.								
		Specifications and Drawings for Application Serial No. 09/696,165, "Semiconductor Device and Method of Manufacturing the Same," Filed on 10/26/00, pp. 1-63, 33 pages of drawings, Inventors: Ritsuko KAWASAKI, et al.								
		Specifications and Drawings for Application Serial No. 09/598,827, "Method of Fabricating a Semiconductor Device," Filed on 06/21/00, pp. 1-64, 25 pages of drawings, Inventor: Kenji KASAHARA.								
		Specifications and Drawings for Application Serial No. 09/732,724, "Semiconductor Device and A Method of Manufacturing the Same," Filed on 12/11/00, pp. 1-50, 26 pages of drawings, Inventors: Ritsuko KAWASAKI et al.								
		Ishihara et al., "Location C Thin-Films," March 1998, Pt. 1, No. 3B.	Control of Large Grain	Following Excimer						

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Complete if Known Substitute for form 1449A/PTO Based on 09/640,077 Application Number INFORMATION DISCLOSURE August 17, 2000 Filing Date STATEMENT BY APPLICANT Ritsuko KAWASAKI, et al. First Named Inventor (use as many sheets as necessary) Group Art Unit 2813 Laura Schillinger Examiner Name Attorney Docket Number Sheet 0756-7181

				U.S. PATENT DOCUMEN	TS		
Examiner Initials	Cite No.1	U.S. Patent Document		Name of Patentee or Applicant of Cited	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number	Kind Code ² (if known)	Document	MM-DD-YYYY		
		5,893,730	- T	Yamazaki et al.	04/13/99		
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		6,492,659		Yamazaki et al.	12/10/02		

			FOREIGN PATENT DOC	UMENTS		
Cite No. 1		·	Name of Patentee or	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	. T ⁶
	Office)	Number ⁴ (if known)	Applicant of Cited Document	MM-DD-YYYY		
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Cite No.1			journal, serial, symposium, catal	og, etc.), date, page(s), volum		T ²
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	No.1	No. I Office's JP	Cite Foreign Patent Document	Cite No.1 Proving Patent Document Name of Patentee or Applicant of Cited Document	No. 1 Name of Patentee or Applicant of Cited Document MM-DD-YYYY	Cite No. 1 Foreign Patent Document Name of Patentee or Applicant of Cited Document MM-DD-YYYY Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

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